



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Response Under 37 C.F.R. § 1.116 Expedited Procedure

In re application of: James F. Orsillo

Application No. 10/695,245

Filed: October 27, 2003 Confirmation No. 4337

For: APPARATUS AND METHOD FOR USE

IN TESTING A SEMICONDUCTOR

WAFER

Examiner: Jermele M. Hollington

Art Unit: 2829

Attorney Reference No. 6427-65559-01

MAIL STOP AF COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: MAIL STOP AF, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney or Agent for Applicant(s)

Date Mailed December 22, 2005

AMENDMENT AFTER ALLOWANCE

Please amend the referenced application as follows:

Amendments to the Specification begin on page 2.

Remarks begin on page 3.

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